

PATENT Docket No. C 2397 COGG

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Zech, et al.

Serial No. 10/075,726

Examiner: Unknown

Filed: 02/14/2002

Art Unit: 1743

Title: CHIP REACTORS HAVING AT LEAST TWO DIFFERENT

MICROREACTION CHANNELS

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on 06-25-02

June 25, 2002

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Roll A. Stowl Signature of certifier

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Typed or printed name of certifier

## INFORMATION DISCLOSURE STATEMENT

**Commissioner for Patents** Washington, DC 20231

Sir:

Transmitted herewith is an Information Disclosure Statement ("IDS") in the abovereferenced application, together with an IDC form listing all references cited and a copy of each reference.

No Office Action on the above-referenced application has been received by Applicant, and therefore no fee for submitting this IDS is believed to be due. However, the

Serial No. 10/075,726

Art Unit: 1743

Commissioner is hereby authorized to charge Deposit Account No. <u>50-1177</u> if any fee under 37 C.F.R. 1.17 is deemed necessary for the accompanying references to be considered by the Patent and Trademark Office.

Some of the references are neither in English nor cited in any accompanying English language version of a search report by another patent office, and therefore require a concise explanation of relevancy, as it is currently understood by the applicant, pursuant to 37 C.F.R. § 1.98(a)(3). This required explanation of relevancy is given in the specification of the above captioned application for the following references:

Reference Identification

Described in Specification at:

EP 0903174 A1

Page 1, Lines 10-12

Respectfully submitted,

TORSTEN ZECH, ET AL.

(Date)

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Enclosure: IDC (w/references)

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<sup>\*</sup> EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.